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CONFIRMATION NO. 3542

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/561,957		117	1791	126273

APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP04/08725 06/21/2004

** FOREIGN APPLICATIONS *****

JAPAN 2003-182615 06/26/2003

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

06/06/2006

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No				
Verified and	/SEYED MASOUD MALEKZADEH/ Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	JAPAN	12	21
Acknowledged					3

ADDRESS

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TITLE

Method for producing silicon epitaxial wafer and silicon epitaxial wafer

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